IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Yasunobu SUGIMOTO et al. Art Unit: Application No.: filed concurrently Examiner:

Filed : February 19, 2004

Title : NITRIDE SEMICONDUCTOR DEVICE

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Sir:

Pursuant to their duty of good faith and candor as set forth in 37 CFR 1.56(a), applicants request that the enclosed reference cited on attached form PTO-1449 be considered by the Examiner in connection with the search of the prior art required by 37 CFR 1.104.

Please note that Japanese Patent Publication No. 2000-299528 is discussed on page 3 of the specification. An English language abstract of this Japanese reference is also enclosed.

This Statement is being filed under 37 CFR 1.97(b) prior to the mailing date of a first Office Action on the merits.

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

Applicants' undersigned attorney may be reached at the telephone number listed below.

Respectfully submitted,

Date: February 19, 2004

Randolph A. Smith Reg. No. 32,548

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Substitute for form 1449A/PTO					Complete if Known			
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STATEMENT BY APPLICANT					Filing Date	February 19, 2004		
					Applicants	Yasunobu SUGIMOTO et al.		
(use as many sheets as necessary)					Group Art Unit			
					Examiner Name			
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EXAMINER DATE CONSIDERED

^{*}Examiner: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹Unique citation designation number. ²Applicant is to place a check mark here if English language Translation is attached. ³Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶Applicant is to place a check mark here if English language Translation is attached.